

## Plasmonic *hot-electron* reconfigurable photodetector based on phase-change material $\text{Sb}_2\text{S}_3$ : supplement

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# Plasmonic *hot-electron* reconfigurable photodetector based on phase-change material $\text{Sb}_2\text{S}_3$

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## 1. Quantum efficiency

In general, hot-electron based photodetectors present low quantum efficiencies. Nevertheless, this is a compromised condition in exchange for absorption at energies below the band gap. The quantum efficiency depends on the operational spectral range of the photodetector. As the wavelength is increased, the quantum efficiency decreases. This is why, as the proposed photodetector works in the telecom wavelengths, the quantum efficiency is low. In Fig. S1, we represent the quantum efficiency for both phases. For comparison, another hot electron photodetector (with no reconfigurability) working at the C band has been reported in literature with quantum efficiency of 0.2%. [1].

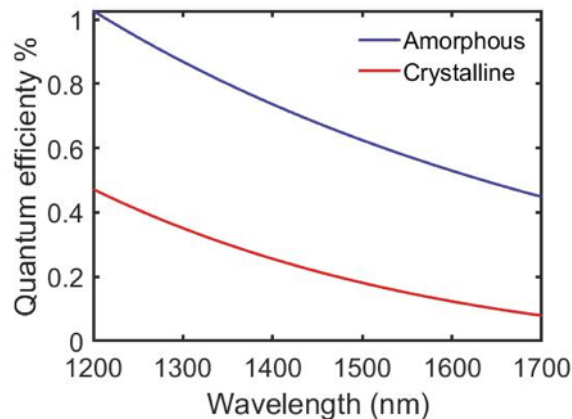


Fig. S1. Quantum efficiency of the proposed photodetector as a function of the wavelength for both phases of  $\text{Sb}_2\text{S}_3$  (crystalline in blue and amorphous in red) . .

25 **2. Thickness dependence and substrate effect.**

26 In the manuscript,  $\text{Sb}_2\text{S}_3$  has been considered as substrate (i.e.,  $\text{Sb}_2\text{S}_3$  of infinite thickness).  
27 Nevertheless, the experimentally switch of  $\text{Sb}_2\text{S}_3$  between its both phases has only been  
28 demonstrated for thicknesses in the range of tens of nanometers. Therefore, for a more realistic  
29 consideration of the studied system, the first step is to calculate the plasmon depth in the  $\text{Sb}_2\text{S}_3$   
30 as function of the PCM layer. This penetration depth  $d$  can be calculated from equation 1.

$$d = \frac{\lambda}{2\pi} \cdot \sqrt{\frac{|\epsilon_g| + \epsilon_{PCM}}{\epsilon_{PCM}^2}} \quad (1)$$

31 where  $\lambda$  is the wavelength, and  $\epsilon_{PCM}$  and  $\epsilon_g$  are the real part of the dielectric function of the  
32 PCM and gold respectively.

33 As shown in Figure S2, the plasmon depth is around 253 nm for both resonant wavelengths  
34 and both phases (1310 – amorphous and 1550 nm- crystalline).

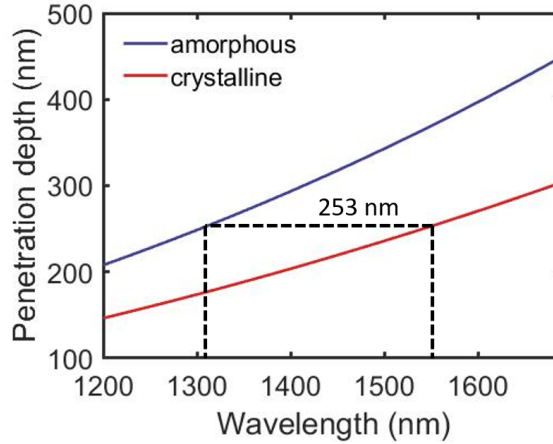


Fig. S2. Plasmon penetration depth in  $\text{Sb}_2\text{S}_3$  for both phases (amorphous in blue and crystalline in red). The plasmon depth for both resonant wavelengths: 1310 nm - amorphous and 1550 nm - crystalline is around 253 nm.

35 The second step is to calculate the absorbance of the proposed design for different thicknesses  
36 of the PCM in order to make a more realistic stimulation of the photoresponsivity of the device.  
37 The PCM is on top on a silicon substrate. In Figure S3, the second plasmon order has been  
38 simulated for different thicknesses of antimony sulphide. For thicknesses higher than 300 nm  
39 (near plasmon depth) plasmon peaks can be generated. However, the amplitude of these peaks is  
40 not as high as for the infinite thickness reported in the paper. Thickness should be increased for  
41 this purpose. From a thickness of 800 nm the absorbance is exactly as if the PCM is treated as  
42 a substrate. So, this should be the thickness of the PCM to achieve the results obtained in the  
43 manuscript.

44 The same simulations have been performed setting different materials as substrate as shown  
45 Figure S4. For a thickness of 800 nm the proposed design for the second plasmon order is  
46 simulated over a glass ( $\text{SiO}_2$ ) and a sapphire ( $\alpha\text{-Al}_2\text{O}_3$ ) substrate. In this case, as the refractive  
47 index of the PCM is higher than the one of the substrate materials ( $\text{SiO}_2$  and  $\alpha\text{-Al}_2\text{O}_3$ ), interference  
48 fringes are produced leading to the appearance of extra peaks in the absorbance spectra. To avoid  
49 this, only a Si, or other materials with a higher refractive index than the PCM, have to be used as  
50 substrate.

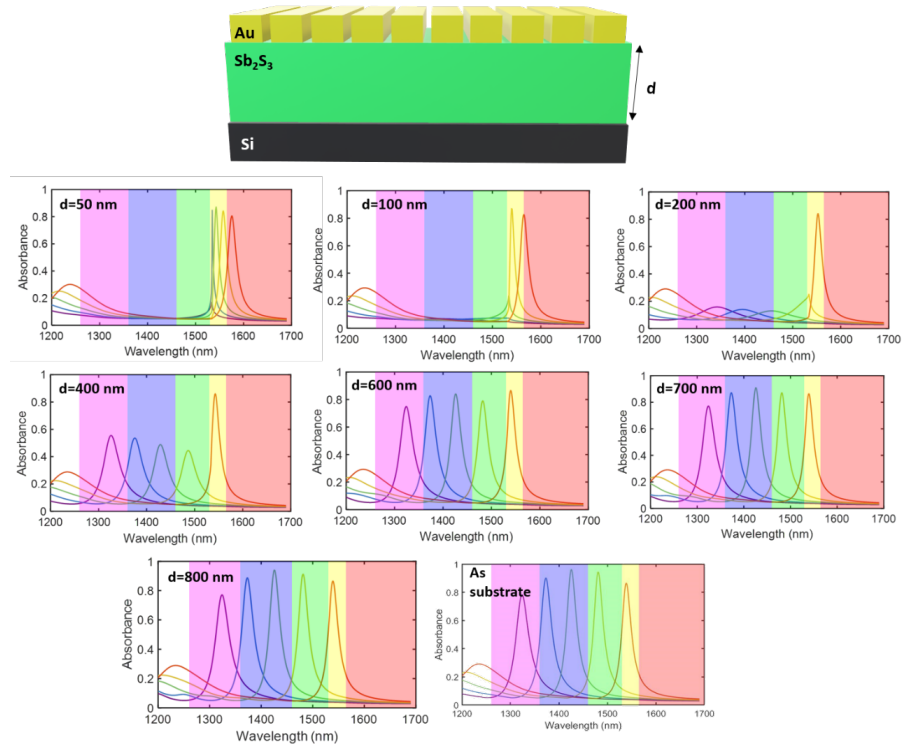


Fig. S3. Absorption spectra of the proposed photodetector for the second plasmon order and for amorphous, crystalline and the intermediate states by changing the thickness  $d$  of Sb<sub>2</sub>S<sub>3</sub> over a silicon substrate. The thicknesses have been varied from  $d=50$  nm to  $d=800$  nm and finally, considered as a substrate.

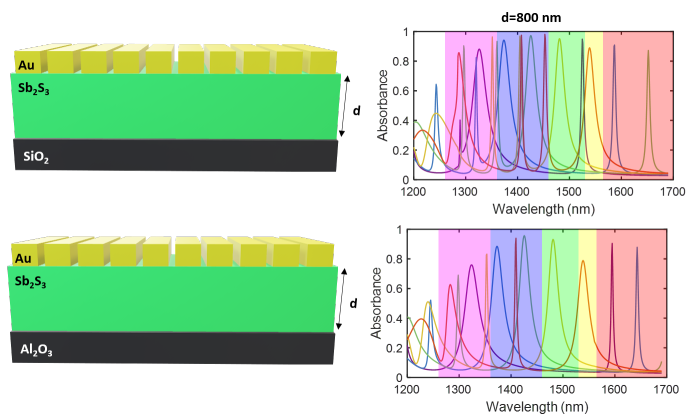


Fig. S4. Absorption spectra of the proposed photodetector for the second plasmon order and for amorphous, crystalline and the intermediate states for a thickness  $d = 800$  nm of Sb<sub>2</sub>S<sub>3</sub> over a glass and a sapphire substrate.

51 **3. The use of a capping layer**

52 A capping layer has been modelled in order to avoid the oxidation of the PCM and to prevent the  
 53 reshaping of the grating at high temperatures required for amorphization.

54 The capping layer can be located between the gold ribs and the PCM. 3 different capping  
 55 layers have been simulated. The materials considered for the capping layer are the most common  
 56 ones used in experiments:  $\text{SiO}_2$ ,  $\text{Si}_3\text{N}_4$  and  $\text{ZnS}$ . The plasmonic response is analysed for the  
 57 three materials and for thickness ranging from 0 to 5 nm. This study has been performed for  
 58 the second plasmon order as it is the one producing higher absorbance. The introduction of the  
 59 capping layer does not alter the values of the absorbance, and therefore, of the photoresponsivity.  
 60 Nevertheless, the plasmon resonances are blueshifted as we are introducing another medium with  
 61 lower refractive index than the PCM. As shown in Figure S5, the higher refractive index of the  
 62 capping layer, the lower the blueshift of the resonance. This shift due to the introduction of the  
 63 capping layer can be considered to recalculate the periods.

Capping layer plasmonic response

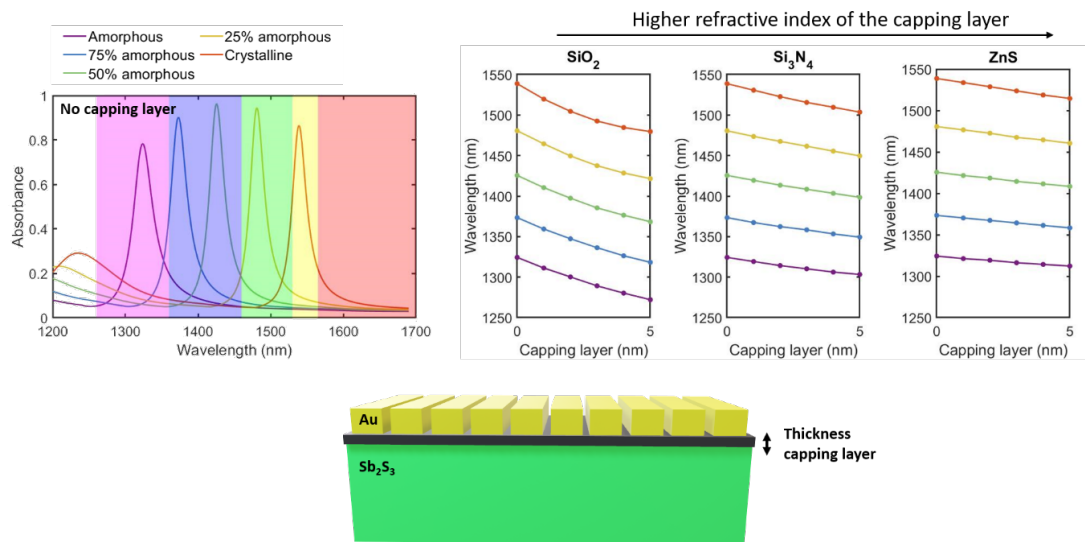


Fig. S5. Absorption spectra of the proposed photodetector for the second plasmon order and for amorphous, crystalline and the intermediate states considering  $\text{Sb}_2\text{S}_3$  as a substrate. The wavelength of the resonant peaks are studied as a function of the thickness of the capping layer. The different materials for the capping layer are:  $\text{SiO}_2$ ,  $\text{Si}_3\text{N}_4$  and  $\text{ZnS}$  and its thickness have been varied from 0 to 5 nm. This capping layer is located between the gold ribs and the PCM.

64 It should be noted that the introduction of a capping layer between the metal and the PCM  
 65 may affect the Schottky barrier. As the energy band gaps of the capping layers ( $\text{SiO}_2$  - (7.5  
 66 -9.2 eV) [2],  $\text{Si}_3\text{N}_4$  - (4.5-5.33 eV) [3] and  $\text{ZnS}$  - (3.6 eV) [4]) are higher than the ones of the  
 67  $\text{Sb}_2\text{S}_3$ , the value of the Schottky barrier its expected to increase. Moreover, as the Schottky  
 68 barrier increases, the photoresponsivity is expected to decrease. To the best of our knowledge,  
 69 no theoretical or experimental data is available in literature to predict the alteration in the value  
 70 of the Schottky battier by introducing any of the previous layers between Au and  $\text{Sb}_2\text{S}_3$ . From  
 71 this arguments, what can be expected is that  $\text{ZnS}$  is the best candidate as: (i) the blueshift in

72 the plasmonic resonance is lower, and (ii) the Schottky barrier will experience the slightest  
73 modification as ZnS presents the lower bandgap.

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